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<p>Form PTO-1449</p> <p style="text-align: center;">INFORMATION DISCLOSURE CITATION IN AN APPLICATION</p> <p>(Several sheets if necessary)</p>				Document Number (Priority) <u>TSMC-00-268</u>	Application Number <u>10/615,744</u>		
				Applicant <u>Yi-Lung Cheng et al.</u>			
				Filing Date <u>07/09/03</u>	Occurrence <u>3</u>		
U. S. PATENT DOCUMENTS							
Examiner Initials	DOCUMENT NUMBER	DATE	ISSUE	CLASS	SUBCLASS	SEARCH DATE X APPROPRIATE	
<u>ML</u>	60777646	6/20/00	Sugiarto et al.	438	597	<u>4/21/97</u>	
<u>ML</u>	62217934	3/24/01	Ngo et al.	438	788	<u>3/1/00</u>	
<u>ML</u>	5827785	10/27/98	Bhan et al.	438	784	<u>10/24/98</u>	
<u>ML</u>	5429995	7/4/95	Nishiyama et al.	437	238	<u>7/16/93</u>	
<u>ML</u>	6242338	6/5/01	Liu et al.	438	622	<u>10/22/99</u>	
<u>ML</u>	6136680	10/24/00	Lai et al.	438	597	<u>1/21/00</u>	
<u>ML</u>	6103601	8/15/00	Lee et al.	438	513	<u>6/10/99</u>	
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
OTHER DOCUMENTS (Including Author, Title, Date, Page(s), Etc.)							
EXAMINER	<u>Michelle Estrada</u>			DATE CONSIDERED		<u>7/7/04</u>	
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

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